

# **INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

Form PTO-1449 (Modified)  
(Use several sheets if necessary)

**COMPLETE IF KNOWN**

Application Number 307090,869  
Confirmation Number 5296  
Filing Date March 4, 2002  
First Named Inventor Scott E. Moore  
Group Art Unit 1741  
Examiner Name  
Attorney Docket No. 108298544US

Sheet 1 of 4

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## **U.S. PATENT DOCUMENTS**

Examiner Initials*	Cite No.	U.S. Patent or Application		Name of Patentee or Inventor of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		NUMBER	Kind Code (if known)			
DN	AA	U.S. Application No. 09/651,779 (Atty. Docket No. 10829.8515US)		Moore	Filed 08/30/2000	
DN	AB	U.S. Application No. 09/651,808 (Atty. Docket No. 4373US)		Chopra et al.	Filed 08/30/2000	
DN	AC	U.S. Application No. 09/653,392 (Atty. Docket No. MTI-31044)		Chopra et al.	Filed 08/31/2000	
DN	AD	U.S. Application No. 09/887,767 (Atty. Docket No. 10829.8515US2)		Lee et al.	Filed 06/21/2001	
DN	AE	U.S. Application No. 09/888,002 (Atty. Docket No. 10829.8515US3)		Lee et al.	Filed 06/21/2001	
DN	AF	U.S. Application No. 09/888,084 (Atty. Docket No. 10829.8515US1)		Lee et al.	Filed 06/21/2001	
DN	AG	U.S. Application No. 10/230,463 (Atty. Docket No. 10829.8672US)		Lee et al.	Filed 08/29/2002	
DN	AH	U.S. Application No. 10/230,602 (Atty. Docket No. 10829.8674US)		Chopra	Filed 08/29/2002	
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*Imaad R. Valentine*

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Confirmation Number 5296  
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First Named Inventor Scott E. Moore  
Group Art Unit 1741  
Examiner Name  
Attorney Docket No. 108298544US

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		NUMBER	Kind Code (if known)			
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DN	AQ	5,575,885		Hirabayashi et al.	11/19/1996	
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*Donald R. Valentine*

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Application Number 20/090,869  
Confirmation Number 5296  
Filing Date March 4, 2002  
First Named Inventor Scott E. Moore  
Group Art Unit 1741  
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Attorney Docket No. 108298544US

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CG	WO	00/26443		Talieh	05/11/2000		
CH	WO	00/28586		Chopra	05/18/2000		
CI	WO	00/32356		Talieh	06/08/2000		

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				Application Number	6,090,869
				Confirmation Number	5296
				Filing Date	March 4, 2002
				First Named Inventor	Scott E. Moore
				Group Art Unit	1741
				Examiner Name	
				Attorney Docket No.	108298544US

Sheet	4	of	4
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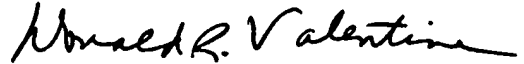
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		Office	NUMBER					
DM	CJ	WO	00/59008		Talieh	10/05/2000		
DM	CK	WO	00/59682		Talieh	10/12/2000		

### OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume issue number(s), publisher, city and/or country where published.	T
DM	CL	FRANKENTHAL, R.P. and EATON, D.H., "Electroetching of Platinum in the Titanium-Platinum-Gold Metallization on Silicon Integrated Circuits," <i>Journal of The Electrochemical Society</i> , Vol. 123, No. 5, pp. 703-706, May 1976.	
DM	CM	BERNHARDT, A.F., CONTOLINI, R.J., MAYER, S.T., "Electrochemical Planarization for Multi-Level Metallization of Microcircuitry," <i>CircuiTree Journal</i> , Vol. 8, No. 10, pp. 38, 40, 42, 44, 46, and 48, Oct. 1995.	
DM	CN	McGraw-Hill, <i>Concise Encyclopedia of Science &amp; Technology</i> , Sybil P. Parker, Editor in Chief, Fourth Edition, p. 367, McGraw-Hill, New York, New York, 1998. (No Month)	
DM	CO	HUANG, C.S. et al., "A Novel UV Baking Process to Improve DUV Photoresist Hardness," 1999 International Symposium on VLSI Technology, Systems, and Applications: Proceedings of Technical Papers: June 8-10, 1999, Taipei, Taiwan, pp. 135-138, IEEE, August 1, 1999.	
DM	CP	ATMI, Table of Contents, Adapted from a presentation at the Semicon West '99 Low Dielectric Materials Technology Conference, July 12, 1999, pp. 13-25.	
DM	CQ	KONDO, S. et al., "Abrasive-Free Polishing for Copper Damascene Interconnection," <i>Journal of the Electrochemical Society</i> , 147(10), pp. 3907-3913 (2000). (No month)	
DM	CR	Micro Photonics, Inc., CSM Application Bulletin, "Low-load Micro Scratch Tester (MST) for characterisation of thin polymer films," <a href="http://www.microphotonics.com/mstABpoly.html">http://www.microphotonics.com/mstABpoly.html</a> , 7/25/2002, 3 pages.	
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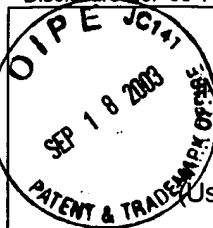
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Express Mail No. EV335522924US

Attorney Docket No. 108298544US

Disclosure No. 00-1194



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## COMPLETE IF KNOWN

Application Number 10/090,869  
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 Filing Date March 4, 2002  
 First Named Inventor Scott E. Moore  
 Group Art Unit 1742  
 Examiner Name Donald R. Valentine  
 Attorney Docket No. 108298544US

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		NUMBER	Kind Code (if known)			
REV		U.S. Application No. 09/653,411		Lee et al.	Filed 08/31/2000	
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		Office	NUMBER	Kind Code (if known)				
REV		EP	0459397	A2, A3	Kabushiki Kaisha Toshiba	12/04/1991		
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REV		WO	02/064314	A1	Speedfam-IPEC Corporation	08/22/2002		

## OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume issue number(s), publisher, city and/or country where published.	T
REV		PCT Written Opinion dated June 10, 2003 for PCT/US02/19495 filed June 20, 2002 (7 pages).	

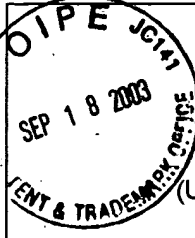
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